

Notice of References Cited	Application/Control No. 10/784,420		Applicant(s)/Patent Under Reexamination DELEFEVRE, PATRICK Y.	
	Examiner Gregory M. Desire		Art Unit 2624	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,256,623	07-2001	Jones, William P.	707/3
*	B	US-2002/0118096	08-2002	Hoyos et al.	340/5.52
*	C	US-6,519,564	02-2003	Hoffberg et al.	704/270.1
*	D	US-6,598,051	07-2003	Wiener et al.	707/100
*	E	US-6,701,317	03-2004	Wiener et al.	707/10
*	F	US-6,748,375	06-2004	Wong et al.	707/3
*	G	US-6,990,453	01-2006	Wang et al.	704/270
*	H	US-2006/0018506	01-2006	Rodriguez et al.	382/100
*	I	US-7,007,076	02-2006	Hess et al.	709/219
*	J	US-7,099,861	08-2006	Youn, Seok Ho	707/3
*	K	US-7,149,741	12-2006	Burkey et al.	707/100
*	L	US-7,167,574	01-2007	Kim, Changick	382/100
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	X	

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